

**AMENDMENTS TO THE SPECIFICATION**

Please replace the following paragraph with the one provided below:

**In the paragraph beginning at page 9, line 31:**

- a diffusion barrier ~~220~~ 270 geometry interposed between the gas 202 and the wafers T, meaning that the gas 202 must go around the diffusion barrier ~~220~~ 270 prior to flowing over the wafers (this type of configuration is illustrated in Figs. 5a and 5c).